

NOV 18 2005

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of:

Chang-Ming Dai

Serial No.: 10/781,182

Filed: February 18, 2004

For: **Full Sized Scattering Bar ALT-PSM Technique  
for IC Manufacturing in Sub-Resolution ERA**

Group Art Unit: 2825

Examiner: Dinh, Paul

Confirmation No.: 1820

TKHR Docket: 252016-2731

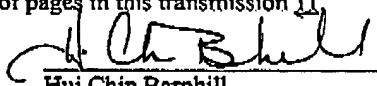
Top-Team: 0503-7594DUS

**CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR §1.8**

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted on the date indicated below via facsimile to the United States Patent and Trademark Office, Technology Group 2100, facsimile number (571) 273-8300. Total number of pages in this transmission 11.

November 18, 2005

Date

  
Hui Chin Barnhill**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

The Office Action mailed September 21, 2005 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.